Attorney's Docket No.: 12732-171001 / US6695

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Masaharu Nagai et al. Art Unit: 1756

Serial No.: 10/694,986 Examiner: Daborah Chacko Davis

Filed : October 29, 2003 Conf. No. : 5334

Title : METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR

MANUFACTURING SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REPLY TO ACTION OF SEPTEMBER 19, 2007

Please amend the above-identified application as follows:

Amendments to the Claims begin on page 2.

Remarks begin on page 9.